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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/517,750	06/10/2005	Wolfgang Clemens	411000-122	6074
7590 04/30/2007 Carella Byrne Bain Gilfillan			EXAMINER	
5 Becker Farm	Road		HO, HOANG QUAN TRAN	
Roseland, NJ 07068			ART UNIT	PAPER NUMBER
			2818	
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SHORTENED STATUTORY PERIOD OF RESPONSE		MAIL DATE	DELIVERY MODE	
3 MONTHS		04/30/2007	PAPER	

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

	Application No.	Applicant(s)			
	10/517,750	CLEMENS ET AL.			
Office Action Summary	Examiner	Art Unit			
	Hoang-Quan Ho	2818			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply					
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w. - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNI 36(a). In no event, however, may a will apply and will expire SIX (6) MON, cause the application to become Al	CATION. reply be timely filed NTHS from the mailing date of this communication. BANDONED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on 20 November 2006.					
,					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims					
4) Claim(s) <u>1-9</u> is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.	•				
6) Claim(s) <u>1-9</u> is/are rejected.					
7) Claim(s) is/are objected to.	r election requirement				
8) Claim(s) are subject to restriction and/or election requirement.					
Application Papers					
9) The specification is objected to by the Examiner.					
10) The drawing(s) filed on is/are: a) accepted or b) dobjected to by the Examiner.					
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).					
Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).					
11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.					
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).					
a) ☐ All b) ☐ Some * c) ☐ None of: 1. ☐ Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage					
application from the International Bureau (PCT Rule 17.2(a)).					
* See the attached detailed Office action for a list of the certified copies not received.					
		•			
Attachment(s)					
1) Notice of References Cited (PTO-892)		Summary (PTO-413)			
Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO/SB/08)	Paper No(s)/Mail Date 5) Notice of Informal Patent Application				
Paper No(s)/Mail Date	6) Other:				

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DETAILED ACTION

Response to Amendment

Applicant's amendment dated November 20, 2006 in which claims 4 and 6 – 7 were amended, no claim was cancelled, no claim was withdrawn, and no claim was added has been entered of record.

Response to Arguments

Applicant's arguments filed November 20, 2006 have been fully considered.

Applicant's arguments, see pgs. 4 – 7, with respect to the rejection of claims related to Heeger reference have been fully considered but they are not persuasive. The citation of Example 6 from Heeger states: "MEH-PPV is cast onto a film of pure UHMW-PE which has been stretched to a moderate draw ratio (e.g. draw ratio>20, Reference 11)." The examiner asserts from such passage, MEH-PPV is a separate layer that was casted onto another layer, of such film of pure UHMW-PE. Therefore, UHMW-PE has a separate status as being a substrate and/or underlayer, and MEH-PPV is applied on top of. The citation to Reference 11 is in regards to the draw ratio of the UHMW-PE and does not imply that MEH-PPV is blended with UHMW-PE from Reference 11 for which applicants may have overlooked. Also to note, par. 0099, Example 5, above from Example 6 in Heeger teaches that it is known for MEH-PPV to be onto a substrate.

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Applicant's arguments, see pg. 7, with respect to the rejection of claims related to Bradley reference have been fully considered but they are not persuasive. Assuming arguendo that Bradley does not explicitly teaches that the plastics stretched would be advantageous for organic electronic components, Bradley does teach that it is known in the art to have the plastics stretched. Combined with the other references cited, for which those plastics are used for organic electronic components, are therefore valid because they share the same plastics used.

Applicant's arguments, see pg. 7, with respect to the motivation related to "enhance the covered area of the substrate or underlayer" have been fully considered but they are not persuasive. Stretching of any material is inherent to cause a given object to cover more area than the original shape and/or size. In response to applicant's argument, inter alia, that "adding a layer to increase the charge carrier mobility within the functional layer", a recitation of the intended use of the claimed invention must result in a structural difference between the claimed invention and the prior art in order to patentably distinguish the claimed invention from the prior art. If the prior art structure is capable of performing the intended use, then it meets the claim.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

⁽b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

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Claim 5 is rejected under 35 U.S.C. 102(b) as being anticipated by Heeger et al. (U.S. Patent App. Pub. No. 2002/0022284), hereinafter as Heeger.

Regarding claim 5, par. 0102 of Heeger teaches a method of increasing the charge carrier mobility of a conducting or semiconducting layer of organic material, wherein the conducting or semiconducting layer is formed on an undersurface comprising an oriented, stretched (well-ordered) plastics film. Heeger teaches that such OLEDs are fabricated on such substrates and are interconnected to a display by transistors on the same substrate.

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 1 is rejected under 35 U.S.C. 103(a) as being unpatentable over Heeger et al (U.S. Pat. Pub. 2002/0022284) in view of Hagler et al (Phys. Rev. B, vol. 44, no. 16).

Regarding claim 1, par. 0102 of Heeger teaches a substrate and/or underlayer (UHMW-PE) of an electronic component (organic light emitting diode), which substrate or underlayer is to be coated with an organic functional layer (MEH-PPV), wherein said substrate or underlayer comprises a partially crystalline and/or axially stretched (well-

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ordered) (oriented) plastics film such the orderliness of the plastics film enables the application of the functional material thereto in the form of a well-ordered layer (a light emitting diode emits polarized light, the MEH-PPV layer is also oriented).

The axially stretched limitation is not disclosed by Heeger, which indicates that the same axially stretched as that used in Hagler with respect to the copolymer MEH-PPV-PE (page 8654, col. 1, lines 4 – 14 and col. 2, lines 1 – 2 "the draw axis") is used for the UHMW-PE substrate. This allows for polarized light.

Claims 2 – 4 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Heeger et al (U.S. Pat. Pub. 2002/0022284) in view of Hagler et al (Phys. Rev. B, vol. 44, no. 16) and in further view of Bradley (J. Phys. D: Appl. Phys., vol. 20).

Regarding claim 2, Heeger and/or Hagler teaches a substrate as defined in claim 1, but fails to teach wherein the plastics film is at least partially crystalline and/or biaxially stretched. Bradley teaches that it is known in the art to provide a monoaxial stretching of a polymeric film (page 1393, col. 1, lines 5 – 38). Also, one having ordinary skill in the art in the area of polymeric films would know that films could also be biaxially stretched. It would have been obvious to one having ordinary skill in the art at the time the invention was made to provide the device of Heeger and/or Hagler with the plastics film stretched, in order to increase area covered.

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Regarding claims 3 and 8, Heeger and/or Hagler teaches a substrate as defined in claim 1 and 2, but fails to teach wherein the plastics film is monoaxially or biaxially stretched. Bradley teaches that it is known in the art to provide a monoaxial stretching of a polymeric film (page 1393, col. 1, lines 5 – 38). Also, one having ordinary skill in the art in the area of polymeric films would know that films could also be biaxially stretched. It would have been obvious to one having ordinary skill in the art at the time the invention was made to provide the device of Heeger and/or Hagler with the plastics film stretched, in order to increase area covered.

Regarding claim 4, Heeger and/or Hagler teaches a substrate as defined in claims 1 – 3 or 8, wherein the plastics film is selected from any of the group consisting of isotactic polypropylene, polyamide, polyethylene, or polyethylene terephthalate (MEH-PPV as cited in Heeger/Hagler references).

Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Heeger in view of Wakita et al, (U.S. Patent No. 5,546,889), hereinafter as Wakita.

Regarding claim 6, Heeger does not explicitly teaches claim 6 limitations, but Wakita teaches that it is known in the art for the use of a substrate and/or underlayer as definied in any one of claims 1 or 5 for the production of an OFET (Col. 1, lines 10 - 14, col. 12, lines 42 - 53), in order to broaden the advantageous of mobility characteristics in other devices other than LED.

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Claim 7 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Wakita in view of Heeger and further in view of Hagler.

Regarding claim 7, Wakita teaches an organic field effect transistor (OFET), a semiconducting layer of organic material, (MEH-PPV; Col. 12, lines 42 – 53) the semiconductor layer exhibiting a charge carrier mobility of $\mu > 10^{-3}$ cm²/Vs (Col. 12, line 53), however, may not explicitly teaches the rest of the claimed limitations. Heeger and Hagler teaches that it is known in the art to provide a substrate or an underlayer (UHMW-PE) which comprises a partially crystalline and /or axially stretched (well-ordered plastics film) and above and on that substrate or underlayer.

The axially stretched limitation is not disclosed by Heeger, which indicates that the same axially stretched as that used in Hagler with respect to the copolymer MEH-PPV-PE (page 8654, col. 1, lines 4 - 14 and col. 2, lines 1 - 2 "the draw axis") is used for the UHMW-PE substrate, in order to broaden the advantageous of mobility characteristics in other devices other than LED.

Regarding claim 9, Wakita teaches the use of a substrate and/or underlayer as defined in claim 4 for the production of an OFET (see claims 4 and 7 rejections in combination).

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hoang-Quan Ho whose telephone number is (571) 272-8711. The examiner can normally be reached on Monday - Friday, 9 AM - 5 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith can be reached on (571) 272-1907. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/HQH/ Hoang-Quan Ho Junior Examiner April 23, 2007

MATTHEW SMITH SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800